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PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

YOSHINOBU SEKIGUCHI, et al.

Application No.: 10/566,170

Int'l. Filing Date: June 15, 2005

371(c) Date: January 27, 2006

For: SEMICONDUCTOR FILM
MANUFACTURING METHOD
AND SUBSTRATE
MANUFACTURING METHOD

Examiner: Andy Huynh

Group Art Unit: 2818

November 28, 2006

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the documents listed on the enclosed Form PTO-1449. Copies of the listed documents, other than the U.S. patent documents, are enclosed.

Japan 2004-119807, Japan 2003-78117, Japan 2002-280531, and Japan 2001-192300 were cited in the International Search Report and/or Written Opinion which issued in the corresponding international application. A copy of the International Search Report and a copy of the Written Opinion are enclosed.

The following documents are discussed at the following pages of the specification:

<u>Documents</u>	<u>Page(s)</u>
U.S. 6,559,075	1
U.S. 6,071,795	1
Japan 3518455	1
O. Ambacher, et al., Materials Research Society Symposium Proceedings, Vol. 617, 2000, pp. J1.7.1-J1.7.12	1
W. S. Wong, et al., Applied Physics Letters, Vol. 75, No. 10, September 6, 1999, pp. 1360-1362	1-2
Daisuke Morita, et al., Japanese Journal of Applied Physics, Vol. 41, Pt. 2, No. 12B, 2002, pp. L1434-L1436	2

English-language abstracts for the Japanese documents are also enclosed.

This Information Disclosure Statement is being filed before the issuance of a first Office Action on the merits. Therefore, no fee under 37 C.F.R. § 1.97(c)(2) is believed due. Nevertheless, the Commissioner may charge Deposit Account No. 06-1205, should any fee be due for filing this paper.

Applicants request that the above information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be initialed and returned indicating that such information has been considered.

Applicants' undersigned attorney may be reached in our Costa Mesa,
California office at (714) 540-8700. All correspondence should continue to be directed to
our below-listed address.

Respectfully submitted,

A handwritten signature in dark ink, appearing to read "D. Vadnais", is written over a horizontal line.

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